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Device and Process Technologies for Microelectronics, MEMS, Photonics, and Nanotechnology IV

**Hark Hoe Tan
Jung-Chih Chiao
Lorenzo Faraone
Chennupati Jagadish
Jim Williams
Alan R. Wilson**
Editors

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Contents

ix	Conference Committee
xi	Symposium Sponsors

SESSION 1 ELECTROCHROMIC AND MICROFLUIDICS

- 6800 02 **Electrochromic device technology based on nanoporous nanocrystalline thin films on PET foil** [6800-01]
C. G. Granqvist, Uppsala Univ. (Sweden); E. Avendaño, ChromoGenics Sweden (Sweden)
- 6800 03 **Microfluidic photonic crystal nanocavities** [6800-02]
C. L. C. Smith, D. K. C. Wu, M. W. Lee, C. Monat, S. Tomljenovic-Hanic, The Univ. of Sydney (Australia); D. Freeman, S. Madden, The Australian National Univ. (Australia); C. Grillet, The Univ. of Sydney (Australia); B. Luther-Davies, The Australian National Univ. (Australia); H. Giessen, Univ. of Stuttgart (Germany); B. J. Eggleton, The Univ. of Sydney (Australia)
- 6800 04 **Reversible wetting of titanium dioxide films** [6800-03]
A. G. G. Toh, M. G. Nolan, R. Cai, Singapore Institute of Manufacturing Technology (Singapore); D. L. Butler, Singapore Institute of Manufacturing Technology (Singapore) and Nanyang Technological Univ. (Singapore)

SESSION 2 ORGANIC DEVICES AND C-BASED NANOSTRUCTURES

- 6800 05 **The effect of temperature and gas flow on the physical vapour growth of mm-scale rubrene crystals for organic FETs (Invited Paper)** [6800-04]
A. R. Ullah, A. P. Micolich, J. W. Cochrane, A. R. Hamilton, Univ. of New South Wales (Australia)
- 6800 07 **Inkjet printing: a viable tool for processing polymer carbon nanotube composites** [6800-06]
M. in het Panhuis, Univ. of Wollongong (Australia); W. R. Small, Univ. of Hull (United Kingdom)

SESSION 3 NANOWIRES

- 6800 09 **Hydrogen sensors based on percolation and tunneling in films of palladium clusters (Invited Paper)** [6800-08]
J. van Lith, A. Lassesson, Univ. of Canterbury (New Zealand); S. A. Brown, MacdDiarmid Institute for Advanced Materials and Nanotechnology (New Zealand) and Univ. of Canterbury (New Zealand)
- 6800 0A **Engineering of hole-spin polarization in nanowires (Invited Paper)** [6800-09]
U. Zülicke, Massey Univ. (New Zealand), MacdDiarmid Institute for Advanced Materials and Nanotechnology (New Zealand), and Univ. Karlsruhe (Germany); D. Csontos, Massey Univ. (New Zealand)

SESSION 4 MEMS I

6800 0D **A novel 3D low voltage electrostatic RF MEMS switch with two movable electrodes**
[6800-72]
J. Babaei, R. Ramer, T. Hesketh, The Univ. of New South Wales (Australia)

6800 0E **Influence of surface roughness on capillary and Casimir forces** [6800-15]
P. J. van Zwol, G. Palasantzas, J. Th. M. De Hosson, Univ. of Groningen (Netherlands)

SESSION 5 TRANSPORT IN NANOSTRUCTURES AND QUANTUM COMPUTING

6800 0G **Four-tip scanning tunneling microscope for measuring transport in nanostructures (Invited Paper)** [6800-17]
S. Hasegawa, S. Yoshimoto, R. Hobara, Univ. of Tokyo (Japan)

6800 0H **Nuclear spin manipulation in semiconductor nanostructures (Invited Paper)** [6800-18]
K. Muraki, NTT Corp. (Japan); G. Yusa, NTT Corp. (Japan), Tohoku Univ. (Japan), and PRESTO-JST (Japan); Y. Hirayama, NTT Corp. (Japan), Tohoku Univ. (Japan), and SORST-JST (Japan)

SESSION 6 NANOFABRICATION TECHNIQUES

6800 0M **Fabrication of sub-wavelength periodic structures upon high-refractive-index glasses by precision glass molding** [6800-23]
T. Mori, K. Hasegawa, T. Hatano, Konica Minolta Opto, Inc. (Japan); H. Kasa, K. Kintaka, J. Nishii, National Institute of Advanced Industrial Science and Technology (Japan)

SESSION 7 MEMS II

6800 0P **Specialized hybrid batch fabrication process for MEMS RF voltage sensors** [6800-26]
J. Dittmer, Technische Univ. Braunschweig (Germany) and Physikalisch-Technische Bundesanstalt (Germany); R. Judaschke, Physikalisch-Technische Bundesanstalt (Germany); S. Büttgenbach, Technische Univ. Braunschweig (Germany)

6800 0Q **A novel out-of-plane micro-mirror actuator** [6800-27]
A. Michael, C. Y. Kwok, C. Kaalund, Univ. of New South Wales (Australia)

6800 0R **Mechanical characteristics of filter structures for MEMS adaptive infrared detectors**
[6800-28]
H. Huang, S. Liu, The Univ. of Queensland (Australia); J. M. Dell, L. Faraone, The Univ. of Western Australia (Australia)

SESSION 8 PHOTONICS/OPTOELECTRONICS

- 6800 OT **Point defect engineered Si sub-bandgap light-emitting diodes (Invited Paper)** [6800-30]
J. Bao, Harvard Univ. (USA); S. Charnvanichborikarn, The Australian National Univ. (Australia); Y. Yang, Harvard Univ. (USA) and Yunnan Univ. (China); M. Tabbal, Harvard Univ. (USA) and American Univ. of Beirut (Lebanon); B. Shin, Harvard Univ. (USA); J. Wong-Leung, J. S. Williams, The Australian National Univ. (Australia); M. J. Aziz, F. Capasso, Harvard Univ. (USA)
- 6800 OU **Effects of spacer growth temperature on the optical properties of quantum dot laser structures** [6800-31]
N. F. Hasbullah, J. S. Ng, H. Y. Liu, M. Hopkinson, J. P. R. David, T. J. Badcock, D. J. Mowbray, Univ. of Sheffield (United Kingdom); A. M. Sanchez, Univ. de Puerto Real (Spain); R. Beanland, Univ. of Cambridge (United Kingdom)
- 6800 OV **Photodarkening study of gratings written into rare-earth doped optical fibres using a femtosecond laser** [6800-32]
M. L. Åslund, Univ. of Sydney (Australia); N. Jovanovic, Macquarie Univ. (Australia); N. Groothoff, J. Canning, Univ. of Sydney (Australia); G. D. Marshall, Macquarie Univ. (Australia); S. D. Jackson, Univ. of Sydney (Australia); A. Fuerbach, M. J. Withford, Macquarie Univ. (Australia)

SESSION 9 DETECTORS, PV, AND SENSORS

- 6800 OW **Toward very large format infrared detector arrays (Invited Paper)** [6800-33]
S. D. Gunapala, S. V. Bandara, J. K. Liu, J. M. Mumolo, C. J. Hill, D. Z. Ting, E. Kurth, Jet Propulsion Lab. (USA); J. Woolaway, FLIR Systems Inc. (USA); P. D. LeVan, Air Force Research Lab. (USA); M. Z. Tidrow, Missile Defense Agency (USA)
- 6800 OX **Impurities in solar-grade silicon (Invited Paper)** [6800-34]
D. Macdonald, J. Tan, The Australian National Univ. (Australia)
- 6800 OY **Microstructured humidity sensors fabricated by glancing angle deposition: characterization and performance evaluation** [6800-35]
K. M. Krause, A. van Popta, J. J. Steele, J. C. Sit, Univ. of Alberta (Canada); M. J. Brett, Univ. of Alberta (Canada) and National Institute of Nanotechnology (Canada)
- 6800 IO **Sliver solar cells** [6800-38]
E. Franklin, A. Blakers, V. Everett, K. Weber, Australian National Univ. (Australia)

POSTER SESSION

- 6800 II **Photovoltaic properties of ferroelectrics and their applications to optical sensor** [6800-37]
M. Ichiki, H. Furue, T. Kobayashi, Y. Morikawa, K. Nonaka, R. Maeda, National Institute of Advanced Industrial Science and Technology (Japan)

- 6800 12 **Optical and conductivity dependence on doping concentration of polyaniline nanofibers** [6800-39]
H. Qasim, A. Z. Sadek, R. Arsaf, W. Wlodarski, I. Belski, RMIT Univ. (Australia); R. B. Kaner, Univ. of California, Los Angeles (USA); K. Kalantar-zadeh, RMIT Univ. (Australia)
- 6800 13 **Optical characteristics of coated long-period fiber grating and their sensing application** [6800-41]
Z. Gu, Univ. of Shanghai for Science and Technology (China); Y. Xu, Nanyang Technological Univ. (Singapore); C. Deng, Univ. of Shanghai for Science and Technology (China)
- 6800 14 **SOI waveguide fabrication process development using star coupler scattering loss measurements** [6800-43]
K. P. Yap, Carleton Univ. (Canada); J. Lapointe, B. Lamontagne, A. Delge, A. Bogdanov, S. Janz, National Research Council (Canada); B. Syrett, Carleton Univ. (Canada)
- 6800 1A **A micro solar heater for portable energy generation** [6800-50]
R. Zimmerman, G. Morrison, O. The, G. Rosengarten, The Univ. of New South Wales (Australia)
- 6800 1B **Development of a flexible luminous device using hollow cathode discharge** [6800-51]
G. Kim, K. Kim, I. Lim, S. S. Yang, S. Oh, Ajou Univ. (South Korea)
- 6800 1C **Positron annihilation lifetime spectroscopy (PALS) and small angle x-ray scattering (SAXS) of self-assembled amphiphiles** [6800-53]
A. W. Dong, Monash Univ. (Australia); C. Pascual-Izarra, CSIRO Molecular and Health Technologies (Australia); Y.-D. Dong, Monash Univ. (Australia); S. J. Pas, A. J. Hill, CSIRO Molecular and Health Technologies (Australia); B. J. Boyd, Monash Univ. (Australia); C. Drummond, CSIRO Molecular and Health Technologies (Australia)
- 6800 1D **Characterization of epitaxially grown n^+ -GaAs (100) surfaces by SPV-transient** [6800-54]
J. Sinkkonen, S. Novikov, A. Varpula, Helsinki Univ. of Technology (Finland); J. Haapamki, Coherent Finland Oy (Finland)
- 6800 1E **The investigations of InAs quantum dots overgrown on $\text{In}_{0.1}\text{Ga}_{0.9}\text{As}$ surfactant layer and 10° off-angle (100) GaAs substrate** [6800-55]
S.-F. Tang, Chung-Shan Institute of Science and Technology (Taiwan); M.-Y. Hsu, National Taipei Univ. of Technology (Taiwan); C.-D. Chiang, Chung-Shan Institute of Science and Technology (Taiwan); C.-C. Su, National Taipei Univ. of Technology (Taiwan); C.-P. Liu, National Cheng-Kung Univ. (China); Y.-C. Fang, Chung-Shan Institute of Science and Technology (China)
- 6800 1H **Effect of thermal stress and diameter on I-V characteristics of template synthesized Cu-Se heterostructures** [6800-58]
S. K. Chakarvarti, National Institute of Technology, Kurukshetra (India); M. Chaudhri, Kurukshetra Univ. (India)
- 6800 1J **Etching lithium niobate during Ti diffusion process** [6800-60]
V. Sivan, L. Bui, D. Venkatachalam, S. Bhargava, RMIT Univ. (Australia); T. Priest, Defence Science and Technology Organisation (Australia); A. Holland, A. Mitchell, RMIT Univ. (Australia)

- 6800 1L **Single particle and momentum relaxation times in two-dimensional electron systems** [6800-63]
S. J. MacLeod, T. P. Martin, A. P. Micolich, A. R. Hamilton, Univ. of New South Wales (Australia)
- 6800 1M **Optical properties of template synthesized nanowalled ZnS microtubules** [6800-64]
R. Kumar, Haryana College of Technology and Management (India); S. K. Chakarvarti, National Institute of Technology, Kurukshetra (India)
- 6800 1P **Characteristics of hetero-junction diodes based on ion beam sputtered ZnO thin films** [6800-67]
J. Kennedy, J. Pithie, A. Markwitz, GNS Science (New Zealand)
- 6800 1Q **A surface-plasmon resonance phase modulation bio-reaction detection system with (5,1) phase-shifting algorithm** [6800-68]
Y.-H. Chen, National Taiwan Univ. (Taiwan); S.-S. Lee, I-H. Hsu, E. Tseng, National Taiwan Ocean Univ. (Taiwan); C.-K. Lee, National Taiwan Univ. (Taiwan)
- 6800 1R **A novel fabrication method of needle array combined x-ray gray mask with LIGA process** [6800-69]
H. Mekaru, T. Takano, K. Awazu, M. Takahashi, R. Maeda, National Institute of Advanced Industrial Science and Technology (Japan)
- 6800 1S **Design, fabrication, and testing of 3C-SiC sensors for high temperature applications** [6800-70]
M. Pozzi, A. J. Harris, J. S. Burdess, Newcastle Univ. (United Kingdom); P. Argyrakis, K. K. Lee, R. Cheung, Univ. of Edinburgh (United Kingdom); G. J. Phelps, N. G. Wright, Newcastle Univ. (United Kingdom)
- 6800 1T **High sensitivity capacitive MEMS microphone with spring supported diaphragm** [6800-73]
N. Mohamad, P. Iovenitti, Swinburne Univ. of Technology (Australia); T. Vinay, RMIT Univ. (Australia)
- 6800 1V **Novel MEMS-based thermometer with low power consumption for health-monitoring network application** [6800-75]
Y. Zhang, T. Ikehara, J. Lu, T. Kobayashi, M. Ichiki, T. Itoh, R. Maeda, National Institute of Advanced Industrial Science and Technology (Japan)
- 6800 1W **Fabrication of smooth 45° micromirror using TMAH low concentration solution with NCW-601A surfactant on <100> silicon** [6800-76]
Y. W. Xu, A. Michael, C. Y. Kwok, Univ. of New South Wales (Australia)
- 6800 1X **Measurements of silicon dry-etching rates and profiles in MEMS foundries and their application to MEMS design software** [6800-77]
T. Takano, T. Ikehara, R. Maeda, National Institute of Advanced Industrial Science and Technology (Japan)

- 6800 1Y **Mechanical quality factor of microcantilevers for mass sensing applications** [6800-78]
J. Lu, T. Ikehara, Y. Zhang, National Institute of Advanced Industrial Science and Technology (Japan); T. Mihara, Olympus Corp. (Japan); R. Maeda, National Institute of Advanced Industrial Science and Technology (Japan)
- 6800 1Z **Sensing gap reconfigurable capacitive type MEMS accelerometer** [6800-79]
C. H. Je, M. Lee, S. Jung, S. Lee, G. Hwang, C. Choi, Electronics and Telecommunications Research Institute (South Korea)
- 6800 20 **Study on in-situ measuring method for average stress gradient of a MEMS film** [6800-80]
H. Rong, M. Wang, Nanjing Normal Univ. (China)
- 6800 22 **Design and fabrication process of a micropump using bulk Pb(Zr,Ti)O₃ for microfluidic devices** [6800-82]
R. Sakamoto, V. T. Dau, D. V. Dao, K. Tanaka, S. Sugiyama, Ritsumeikan Univ. (Japan)
- 6800 26 **RF-MEMS switches with new beam geometries: improvement of yield and lowering of actuation voltage** [6800-87]
K. Y. Chan, Univ. of New South Wales (Australia); M. Daneshmand, R. R. Mansour, Univ. of Waterloo (Canada); R. Ramer, Univ. of New South Wales (Australia)
- 6800 27 **RF-MEMS switches: design and performance in wireless applications** [6800-88]
H. U. Rahman, J. Babaei, R. Ramer, Univ. of New South Wales (Australia)
- 6800 28 **Nanometric material removal using the electrokinetic phenomenon** [6800-90]
L. C. Seng, Nanyang Technological Univ. (Singapore); T. L. Blackburn, Georgia Institute of Technology (USA); S. H. Ng, Singapore Institute of Manufacturing Technology (Singapore); Y. Chun, Nanyang Technological Univ. (Singapore); D. L. Butler, Nanyang Technological Univ. (Singapore) and Singapore Institute of Manufacturing Technology (Singapore); S. Danyluk, Georgia Institute of Technology (USA)

Author Index

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- 1 Electrochromic and Microfluidics
 Hark Hoe Tan, The Australian National University (Australia)
- 2 Organic Devices and C-based Nanostructures
 Richard J. Blaikie, University of Canterbury (New Zealand)
- 3 Nanowires
 Shuji Hasegawa, The University of Tokyo (Japan)
 Michelle Y. Simmons, University of New South Wales (Australia)
- 4 MEMS I
 Lorenzo Faraone, The University of Western Australia (Australia)
- 5 Transport in Nanostructures and Quantum Computing
 Robert G. Elliman, The Australian National University (Australia)
- 6 Nanofabrication Techniques
 Simon A. Brown, University of Canterbury (New Zealand)
- 7 MEMS II
 Sarath D. Gunapala, Jet Propulsion Laboratory (USA)
- 8 Photonics/Optoelectronics
 Lan Fu, The Australian National University (Australia)
- 9 Detectors, PV, and Sensors
 Alex R. Hamilton, University of New South Wales (Australia)
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